

**Notice of References Cited**

Application/Control No.

10/541,465

Applicant(s)/Patent Under  
Reexamination  
MINO ET AL.

Examiner

Ajay K. Arora

Art Unit

2811

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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	C	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Ariel, Nava et al, "Microelectronically fabricated LiCoO <sub>2</sub> /SiO <sub>2</sub> /polycrystalline-silicon power cells planarized by chemical mechanical polishing", American Vacuum Society J. Vac. Sci. Technol. B 24 (2), Mar/Apr 2006, pg. 562-569
	V	
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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